

<b>INFORMATION DISCLOSURE CITATION</b> <i>(Use several sheets if necessary)</i>				Docket Number (Optional)		Application Number		
				50478-0700		10/573,137		
				Applicant(s)				
				Wataru Ikeda et al.				
				Filing Date		Group Art Unit		
				09/18/2006		2627		
<b>U. S. PATENT DOCUMENTS</b>								
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
		6,434,326	8.13.2002	Kondo et al.				
<b>U.S. PATENT APPLICATION PUBLICATIONS</b>								
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
		2002/0021887	02.21.2002	Yoshikawa				
		2003/0161615	08.28.2003	Tsumagari et al.				
		2002/0186485	12.12.2002	Cho et al.				
<b>FOREIGN PATENT DOCUMENTS</b>								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		2003-249057	9.5.2003	Japan (See US 2003/0161615 Family Patent Application)				
		06-004166	1.14.1994	Japan w/English Abstract			X	
		06-230946	8.19.1994	Japan w/English Abstract			X	
		2001-238161	8.31.2001	Japan w/English Abstract			X	
		2002-57990	2.22.2002	Japan (See US 2002/0021887 Family Patent Application)			X	
		10-063362	3.6.1998	Japan w/English Abstract			X	
		2004-206863	7.22.2004	Japan w/English Abstract			X	
<b>OTHER DOCUMENTS</b> <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>								
		J.C. Newell, "An introduction to MHP 1.0 and MHP 1.1", Internet Article, retrieved from Internet: URL: <a href="http://www.fondazionerosselli.it/DocumentFolder/Referencees_BBC_R&amp;D">http://www.fondazionerosselli.it/DocumentFolder/Referencees_BBC_R&amp;D</a> , 20 pages, May 2002						
EXAMINER				DATE CONSIDERED				
/Marc Dzenski/				04/08/2009				
<b>EXAMINER:</b> Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								

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				09/18/1006		2627	
<b>U. S. PATENT DOCUMENTS</b>							
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<b>FOREIGN PATENT DOCUMENTS</b>							
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES NO
		WO 01/33847	10.05.2001	WIPO/PCT			X
		WO 01/33852	10.05.2001	WIPO/PCT			X
		WO 01/04743	18.01.2001	WIPO/PCT			X
		2003-248637	05.09.2003	Japan w/English Abstract			X
		11-219313	08.10.1999	Japan w/English Abstract			X
		2002-269929	09.20.2002	Japan w/English Abstract			X
		2001-022625	01.26.2001	Japan w/English Abstract			X
		01/35416	05.17.2001	WIPO/PCT			X
		11-18048	1.22.1999	Japan (see US 6,434,326 patent family)			X
		2003-61055	2.28.2003	Japan (see US 2002/0186485 patent family)			X
		2000-149514	5.30.2000	Japan w/English abstract			X
		10-304304	11.13.1998	Japan w/English abstract			X
<b>OTHER DOCUMENTS</b> <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>							
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